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Atty. Docket No. PLA31071

MAR 28 2006

**IN THE UNITED STATES PATENT & TRADEMARK OFFICE**

**IN RE APPLICATION OF:**

Ki-Min LEE : GROUP ART UNIT: 2818

APPLICATION NO: 10/750,489 :

FILED: December 31 , 2003 : EXAMINER: Calvin LEE

FOR: METHODS OF MANUFACTURING  
METAL-INSULATOR-METAL  
CAPACITORS OF HIGH  
CAPACITANCE IN  
SEMICONDUCTOR DEVICES

I hereby certify that this document is being facsimile transmitted to the USPTO or deposited with the United States Postal Service as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on March 28, 2006.

By: Jennie Heaton  
Jennie Heaton

**REQUEST FOR RECONSIDERATION UNDER 35 U.S.C. 132 AND 37 C.F.R. 1.111**

Mail Stop AMENDMENT  
COMMISSIONER FOR PATENTS  
P.O. BOX 1450  
ALEXANDRIA, VA 22313-1450

SIR:

Responsive to the Office Action dated October 28, 2005, Applicant respectfully requests reconsideration of the above-identified application in view of the following remarks.